

EV 335728716 US INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) MTU-01		Application Number PCT/EP2004/003620	
				Applicant(s) Armin Dolker		10/552928	
				Filing Date 10/20 Rec'd PCT/PTO 11 OCT 2005		Group Art Unit	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>AC</i>		US 6,366,049 B1	04/02/02	Chen, et al	318	799	05/10/00
<i>AC</i>		US 5,613,474 A	3/25/97	Nakamura, et al	123	496	08/10/94
U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<i>AC</i>	WO 03/098793 A	11/27/03	PCT	—	—		
<i>AC</i>	DE 102 21 681	11/27/03	Germany	—	—		✓
<i>AC</i>	DE 102 52 399	6/3/04	Germany	—	—		✓
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
EXAMINER <i>Cliff Custer</i>				DATE CONSIDERED <i>12-21-2006</i>			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							